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PATENT
3885-0102P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Hisashi YAMADA et al. Conf.: 2551
Appl. No.: 10/046,739 Group: 2814
Filed: January 17, 2002 Examiner: HOA B. TRINH
For: THIN-FILM CRYSTAL WAFER HAVING PN
JUNCTION AND METHOD FOR FABRICATING THE
WAFER

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

JAN 25 2005

Sir:

Please advise the undersigned as to the status of the above-identified application as follows:

Status of Office Action

A duplicate copy of the present Status Inquiry is attached hereto. It is respectfully requested that the duplicate copy be marked appropriately to indicate the status of the above-identified application and returned to the undersigned as soon as possible.

Please call the undersigned if there are any questions with regard to the present request.

Respectfully submitted,

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- ☐ Awaiting Action from Patent Office Examiner - Expected Date for Action is: _____.
- ☐ Awaiting Decision by Board of Appeals.
- ☐ Application allowed on _____.
- ☐ Abandoned per _____.
- ☐ Other _____.